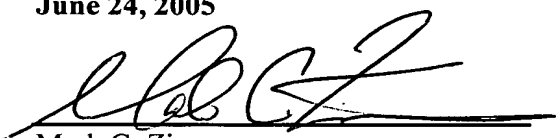


IFW



PATENT
Docket No. 20063/OG03-050

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):)	I hereby certify that this paper and the
)	documents referred to as enclosed
Han et al.)	therewith are being deposited with the
)	United States Postal Service as first
U.S. Serial No.: 10/747,602)	class mail, postage prepaid, in an
)	envelope addressed to Commissioner
For: "Methods of Fabricating)	for Patents, P.O. Box 1450,
Semiconductor Devices")	Alexandria, Virginia 22313-1450 on
)	this date:
Filed: 12/29/2003)	
)	June 24, 2005
Group Art Unit: 2812)	
)	
Examiner: Not Yet Assigned)	Mark C. Zimmerman
)	Attorney for Applicant(s)
)	Registration No. 44,006

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

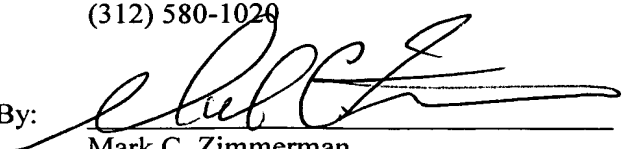
Sir:

Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

June 24, 2005

By: 
Mark C. Zimmerman
Registration No.: 44,006